



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Robert J. Small and Zhefei J. Chen
Title: Compositions for Chemical-Mechanical Planarization of Noble-Metal-Featured Substrates, Associated Methods, and Substrates Produced By Such Methods
Application No.: 10/057,206 Filing Date: January 25, 2002
Examiner: Michael Marcheschi Group Art Unit: 1755
Docket No.: CHEM.003US0 Conf. No.: 1702

RECEIVED
JUN 23 2004
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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PETITION FOR EXTENSION OF TIME

Dear Sir:

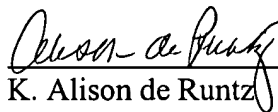
A three-month extension of time within which to respond to the December 18, 2003 outstanding Office Action is respectfully requested, such extension allowing the undersigned until June 18, 2004 to respond.

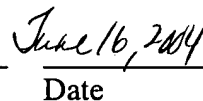
A check is enclosed that includes the amount of \$950.00, as set forth in the enclosed transmittal letter.

**EXPRESS MAIL LABEL
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EV 437668108 US

Respectfully submitted,


K. Alison de Runtz
Reg. No. 37,119


Date

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